

004887.P522
TAV:cad

Patent



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Don E. Curry, et al.

Application No.: 09/828,067

Examiner: RUDY ZERVIGON

Filed: April 6, 2001

Art Unit: 1763

Attorney Docket No.: 004887.P522

For: A WAFER PROCESSING
APPARATUS HAVING A
CHAMBER WITH AN UPPER
WALL HAVING GAS SUPPLY
OPENINGS FORMED THEREIN
WHICH PROMOTE MORE EVEN
PROCESSING OF A WAFER

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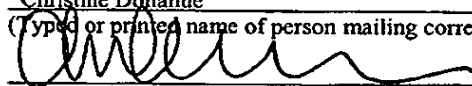
PRELIMINARY AMENDMENT

Sir:

A Request for Continued Examination is filed herewith. It is respectfully requested that such examination be conducted after entry of the following amendments:

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450 on October 23, 2003.

Christine Donahue
(Typed or printed name of person mailing correspondence)


(Signature of person mailing correspondence)